

531 Rec

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Docket: 740819-603

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re National Phase Patent Application of)
Gaku SUGAHARA et al.)
International Application No. PCT/JP00/08461) Attn: US/DO/EO
International Filing Date: November 29, 2000)
For: SEMICONDUCTOR LASER DEVICE,)
METHOD FOR FABRICATING THE)
SAME, AND OPTICAL DISK APPARATUS) Date: July 27, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, D.C. 20231


Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

These references were cited in the International Search Report, a copy of which is submitted herewith.

Respectfully submitted,


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